

**2371-20**

**Advanced Workshop on Energy Transport in Low-Dimensional Systems:  
Achievements and Mysteries**

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**Thermal and Electrical Transport and Thermoelectric Figure-of-Merit in Low-  
Dimensional Nanostructures**

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# **Model for the thermal transport in 3D, 2D and 1D materials**

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# Outlook

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- ▶ Motivation
- ▶ Starting point
- ▶ Boltzmann equation
- ▶ Callaway model
- ▶ Gruyel-Krumshansl model
- ▶ Modified model GKM
- ▶ Results
- ▶ Conclusions

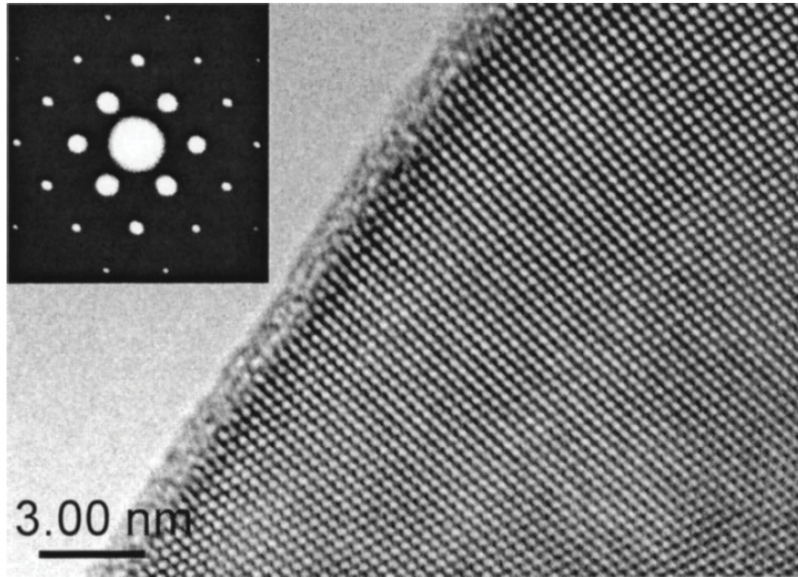


# Motivation

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- ▶ The thermal conductivity of silicon nanowires found in several experimental works
- ▶ Unclear explanation proposed by several authors based on the BTE and several expressions for the different relaxation times involved
- ▶ Several authors have tried to explain the thermal conductivity using classical molecular dynamics, even for the thinnest wires and low temperature
- ▶ In some of the theoretical papers found in the literature, N-processes are not considered at all

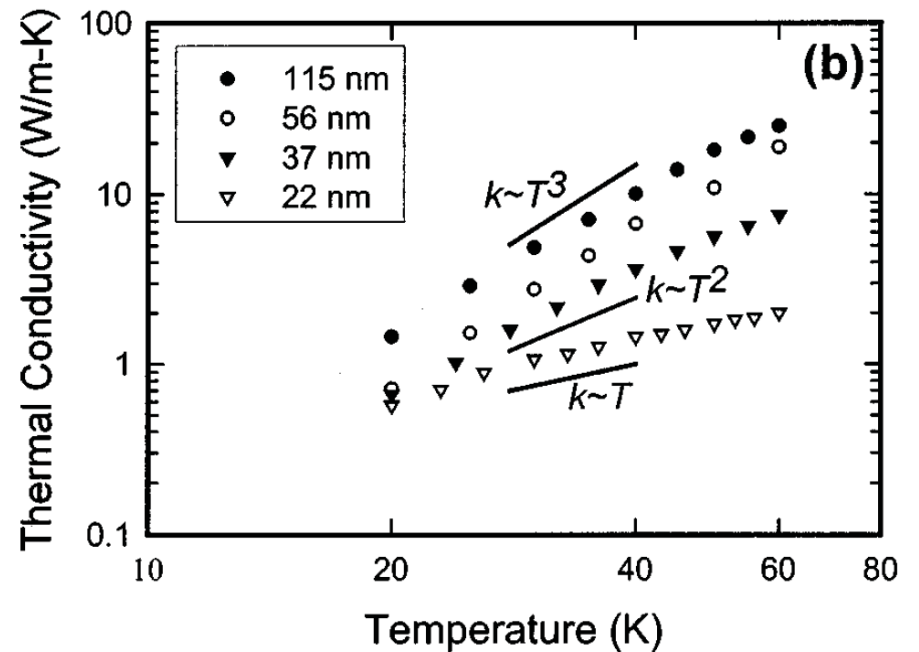
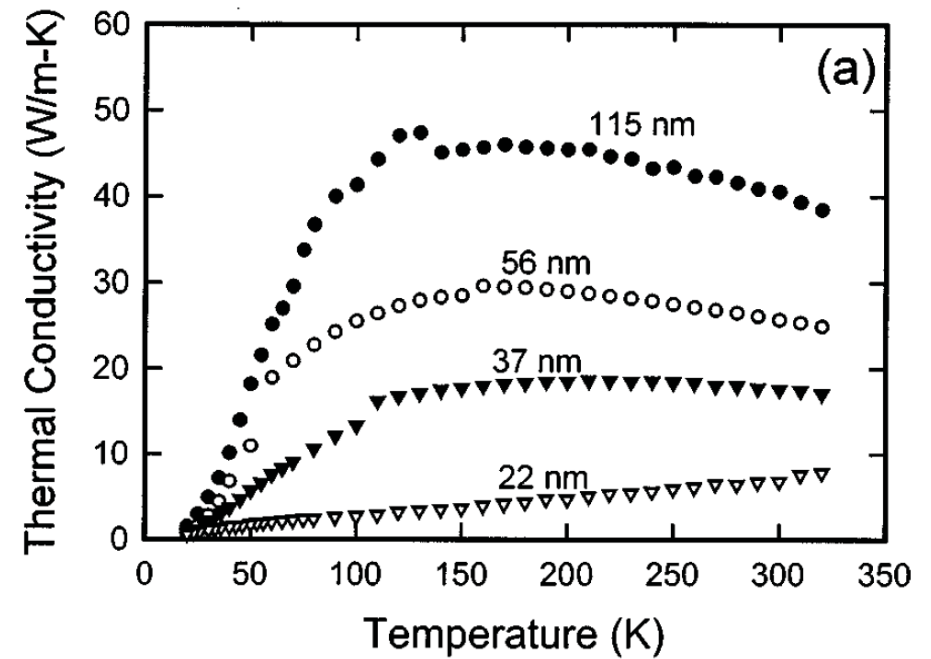




High-resolution TEM image of a 22 nm single crystal Si NW.

(a) Measured thermal conductivity of different diameter Si nanowires. The number beside each curve denotes the corresponding wire diameter.

(b) Low temperature experimental data on a log scale.



Calculation of the contribution of the surface/boundary to the thermal conductivity

$$\Delta \kappa_l^{\text{wire}} = \frac{24}{\pi} \left( \frac{k_B}{\hbar} \right)^3 \frac{k_B}{2\pi^2 V} T^3 \int_0^{\theta_D/T} \frac{\tau_C x^4 e^x}{(e^x - 1)^2} G(\eta(x), p) dx$$

The relaxation time has several contributions:

$$\frac{1}{\tau_C} = \frac{1}{\tau_U} + \frac{1}{\tau_M} + \frac{1}{\tau_B} + \frac{1}{\tau_{\text{ph-e}}}$$

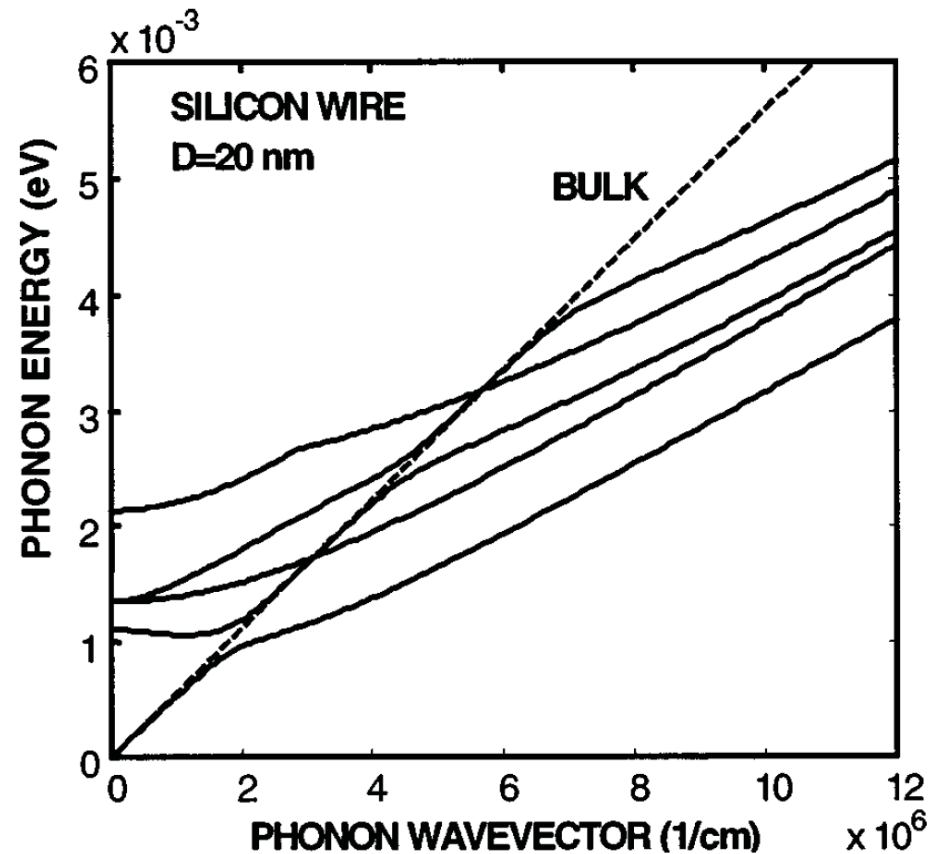
For U-processes,  $\frac{1}{\tau_U} = 2\gamma^2 \frac{k_B T}{\mu V_0} \frac{\omega^2}{\omega_D}$

For mass-defect scattering  $\frac{1}{\tau_M} = \frac{V_0 \Gamma \omega^4}{4\pi V^3}$

For boundary scattering  $\frac{1}{\tau_B} = \frac{V}{D} (1-p)$

Phonon-electron interaction

$$\frac{1}{\tau_{\text{ph-e}}} = \frac{n_e \epsilon_1^2 \omega}{\rho V^2 k_B T} \sqrt{\frac{\pi m^* V^2}{2 k_B T}} \exp\left(-\frac{m^* V^2}{2 k_B T}\right)$$



► J. Zou & A. Balandin, JAP89, 2932 (2001).

## VII. DECAY OF OPTICAL PHONONS INTO ACOUSTIC PHONONS

M. Kazan et al add a term to account for the decay of optical phonons in acoustic phonons, even at 0K!

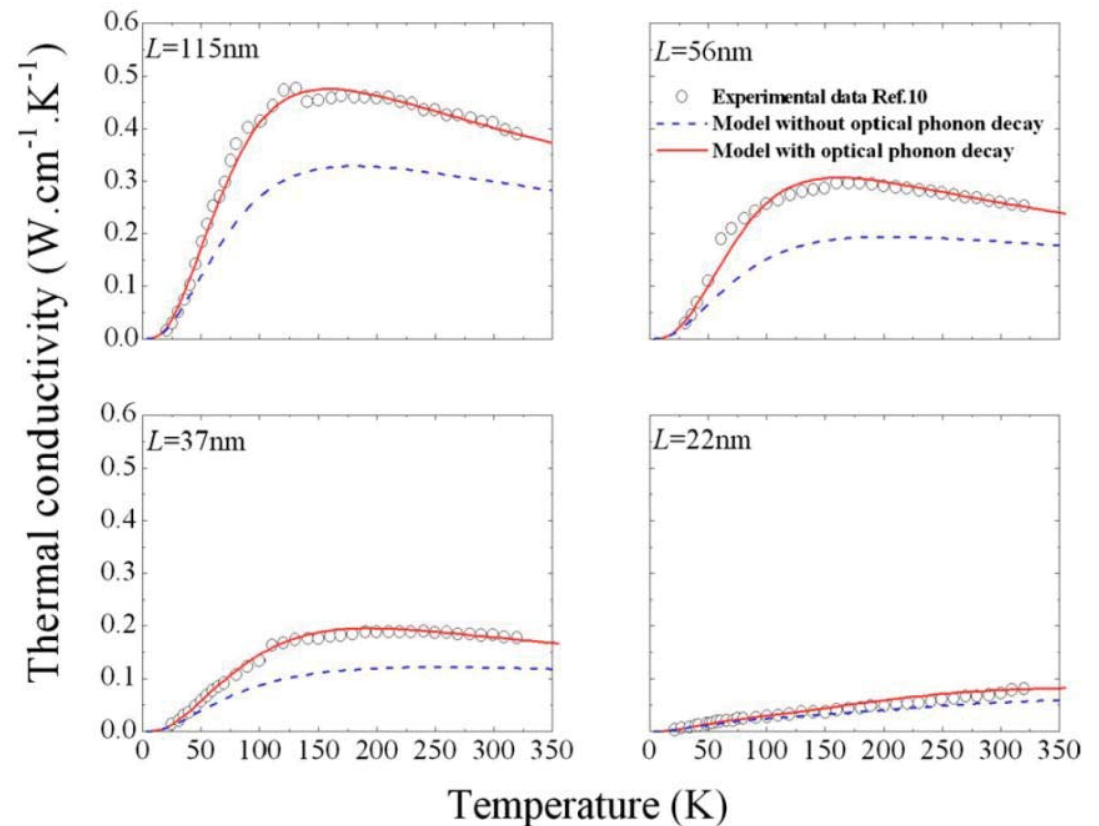
$$\tau^{-1} = - \frac{1}{\tilde{N}_{OP}} \frac{d}{dt} (\tilde{N}_{OP})$$

They subtract the decay involving three or four phonon processes to the remaining resistive processes:

$$\tau_{R,j}^{-1} = (\tau_{B,j}^{-1} + \tau_{I,j}^{-1} - \tau_{G(3),j}^{-1} - \tau_{G(4),j}^{-1}) + \tau_{U,j}^{-1}$$

and gives the following expression for the N-processes

$$\tau_{N,L}^{-1} = B_{N,L} \omega^2 T^3 \quad \tau_{N,T}^{-1} = B_{N,T} \omega T^4$$



Dashed line: without phonon decay. Solid line: including phonon decay.



# Starting point

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- ▶ When the diameter of the NWs is reduced, the boundary or surface effects (classical) are more important
- ▶ Below some diameter, quantum effects may play a role
- ▶ In the 20 to 100 nm range, it is still not clear if quantum effects could be important
- ▶ Several works including physical engineering have been proposed in the literature



## What we propose:

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- ▶ We plan to analyze here the range where classical effects are enough to explain the thermal conductivity
- ▶ Our approach will be based on the BTE to account for the phonon transport
- ▶ We use a lattice dynamics model to obtain the bulk dispersion relations (bond charge model)
- ▶ The calculation of the thermal conductivity will be done using the Gruyer-Krumhansl model (GKM) instead of the previously used, the Callaway-Holland model (CM).



# Callaway model

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Callaway starts from the Boltzmann equation and takes for the collision integral

$$\left(\frac{\partial N}{\partial t}\right)_c = \frac{N(\lambda) - N}{\tau_N} + \frac{N_0 - N}{\tau_u}$$

and writes the classical expression for the thermal conductivity

$$\kappa = \frac{3}{(2\pi)^3} \int c^2 \cos^2\theta \alpha(k) C_{\text{ph}}(k) d^3k$$

He called U-processes to all resistive processes, including impurity or boundary

$$\tau_u^{-1} = A\omega^4 + B_1 T^3 \omega^2 + c/L$$

and gives the following expression for the N-processes

$$\tau_N^{-1} = B_2 T^3 \omega^2$$

The expression for the thermal conductivity is:

$$\kappa = \frac{c^2}{2\pi^2} \int \tau_c \left(1 + \frac{\beta}{\tau_N}\right) C_{\text{ph}} k^2 dk$$

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# Gruyer-Krumhansl model

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In the GKM the BTE is written as:

$$\left[ \frac{\partial}{\partial t} + \mathbf{v} \cdot \nabla - \mathbf{C} \right] f(\mathbf{r}, \mathbf{q}, t) = 0$$

By introducing the drift operator,

$$D = \frac{\partial}{\partial t} + \mathbf{v} \cdot \nabla$$

the BTE can be written in the following form:

$$Df(\mathbf{r}, \mathbf{q}, t) = (\mathbf{R} + \mathbf{N}) f(\mathbf{r}, \mathbf{q}, t)$$

where the collision operator has been divided into two components, one related to the resistive processes and a second component related to N-processes

In order to symmetrized the collision operator, in the GKM the following basis is used:

$$f^*(\mathbf{r}, \mathbf{q}, t) = f(\mathbf{r}, \mathbf{q}, t) 2 \sinh \frac{\hbar \omega_{\mathbf{q}}}{2k_B T}$$

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► R.A. Gruyer and J.A. Krumhansl, PR 148, 766 (1966).

The final form of the linearized BTE is a matrix, given by

$$\left\{ \begin{pmatrix} D_{00} & D_{01} & 0 \\ D_{10} & D_{11} & D_{12} \\ 0 & D_{21} & D_{22} \end{pmatrix} - \begin{pmatrix} 0 & 0 & 0 \\ 0 & 0 & 0 \\ 0 & 0 & N_{22} \end{pmatrix} - \begin{pmatrix} 0 & 0 & 0 \\ 0 & R_{11} & R_{12} \\ 0 & R_{21} & R_{22} \end{pmatrix} \begin{pmatrix} a_0 \\ \mathbf{a}_1 \\ \mathbf{a}_2 \end{pmatrix} \right\} = 0$$

and the thermal conductivity can be written as

$$\kappa = \frac{1}{3} C_v v^2 [\langle \tau_{RB} \rangle (1 - \Sigma) + \langle \tau_R^{-1} \rangle^{-1} G(R) \Sigma]$$

Where the resistive contribution to the relaxation time is

$$\tau_{RB}^{-1} = \tau_I^{-1} + \tau_U^{-1} + \tau_B^{-1}$$

and  $\Sigma$ , called Ziman factor, is given by  $\Sigma = \frac{1}{1 + \langle \tau_N \rangle / \langle \tau_{RB} \rangle}$

with the usual definition of  $\langle \tau \rangle = \frac{2}{3kT} \frac{\int_0^\infty E \tau dn(E)}{\int_0^\infty dn(E)}$



# Hydraulic analogy

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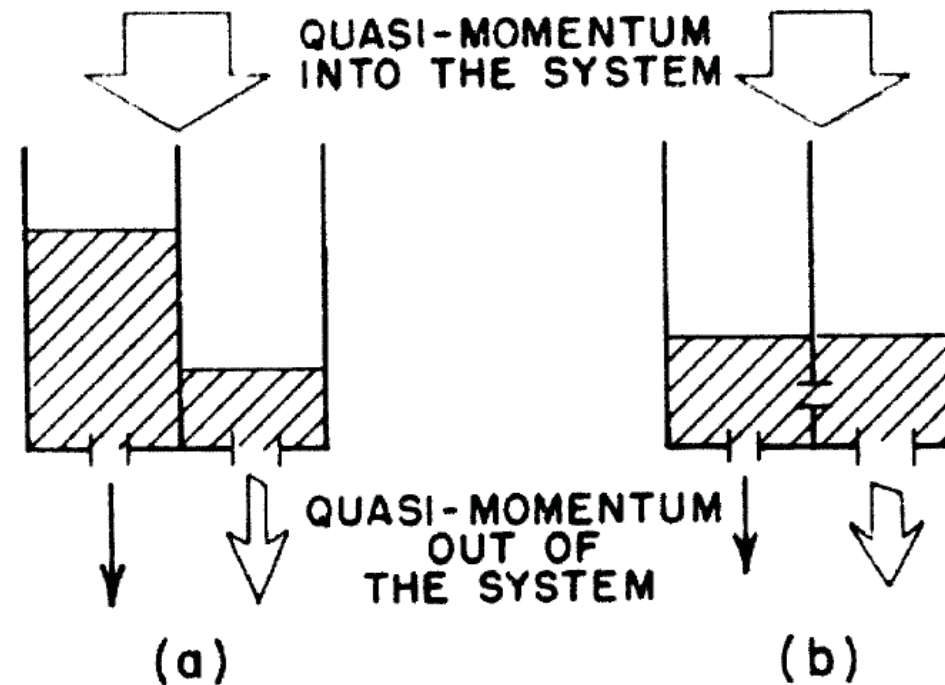


FIG. 1. Schematic analogy of quasimomentum balance in phonon system; (a) represents weak normal processes where various groups of phonons lose momentum individually, while in (b) strong  $N$  processes effectively transfer quasimomentum to the strongly scattered state (indicated by the large arrow).

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The final expression for the thermal conductivity can be written as

$$\kappa = \kappa_k(1 - \Sigma) + \kappa_Z F(\ell/L_{\text{eff}})\Sigma$$

with two components, the kinetic component and the Ziman component. The factor  $F$ , taking into account the geometry of the system is

$$F(\ell/L_{\text{eff}}) = \frac{1}{2\pi^2} \frac{L_{\text{eff}}^2}{\ell^2} \left( \sqrt{1 + 4\pi^2 \frac{\ell^2}{L_{\text{eff}}^2}} - 1 \right)$$

This factor has been derived in previous paper and it has been obtained as an asymptotic expansion of a continued-fraction approximation of the thermal conductivity.

When the normal processes are negligible,

$$\tau_N \rightarrow \infty \quad \Sigma \rightarrow 0$$

and the thermal conductivity is dominated by the kinetic part. When the normal processes are very rapid,

$$\tau_N \rightarrow 0 \quad \Sigma \rightarrow 1$$

and the conductivity is dominated by the Ziman part.

For the scattering by impurities and boundaries we take the standard expressions

$$\tau_I^{-1} = A\omega^4 \quad \tau_B^{-1} = \frac{v}{L_{\text{eff}}}$$

And for the scattering by N and U-processes we used an expression calculated by A.Ward and D.A. Broido by solving the Boltzmann equation with DFT theory

$$\tau_U^{-1} = B_U\omega^4 T [1 - \exp(-3T/\Theta_D)]$$

$$\tau_N^{-1} = \left( \frac{1}{B_N T} + \frac{1}{B'_N T^3} \right)^{-1} \omega^2 [1 - \exp(-3T/\Theta_D)]$$

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► A.Ward and D.A. Broido, PRB81, 085205 (2010).

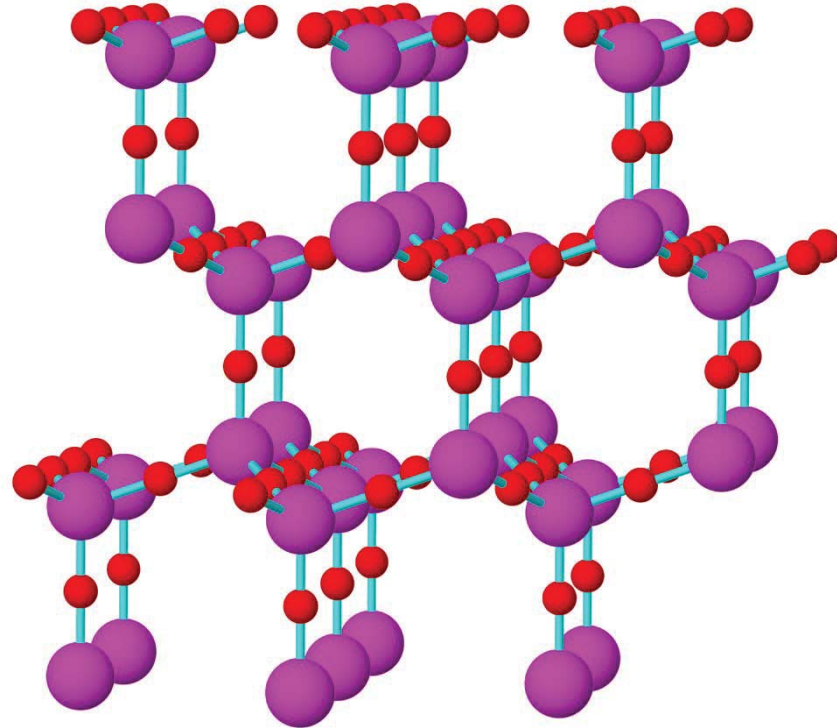


# Adiabatic bond charge model

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Parameters:

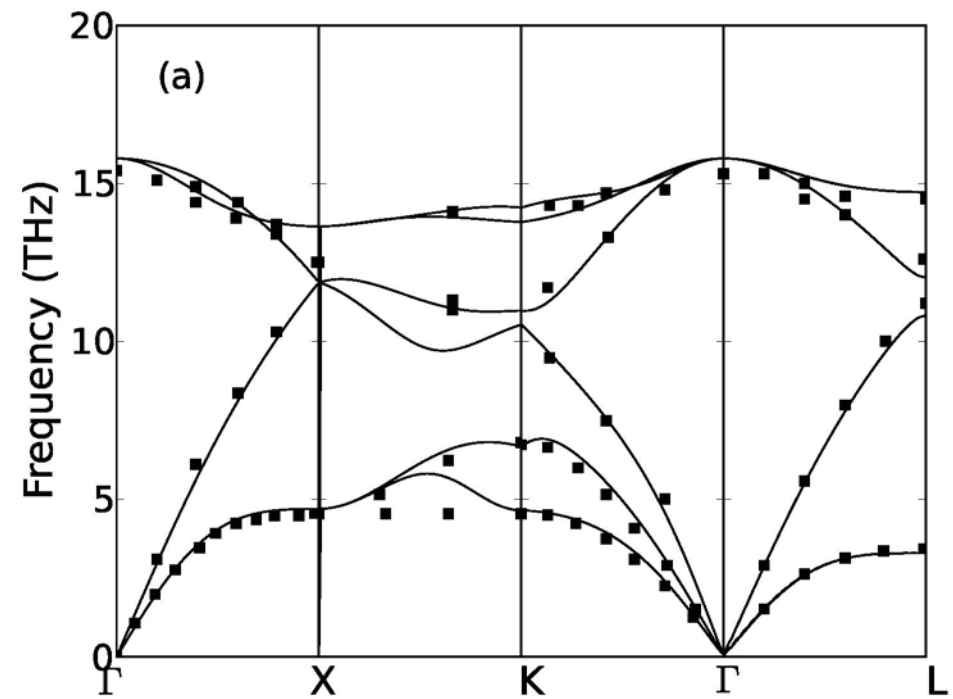
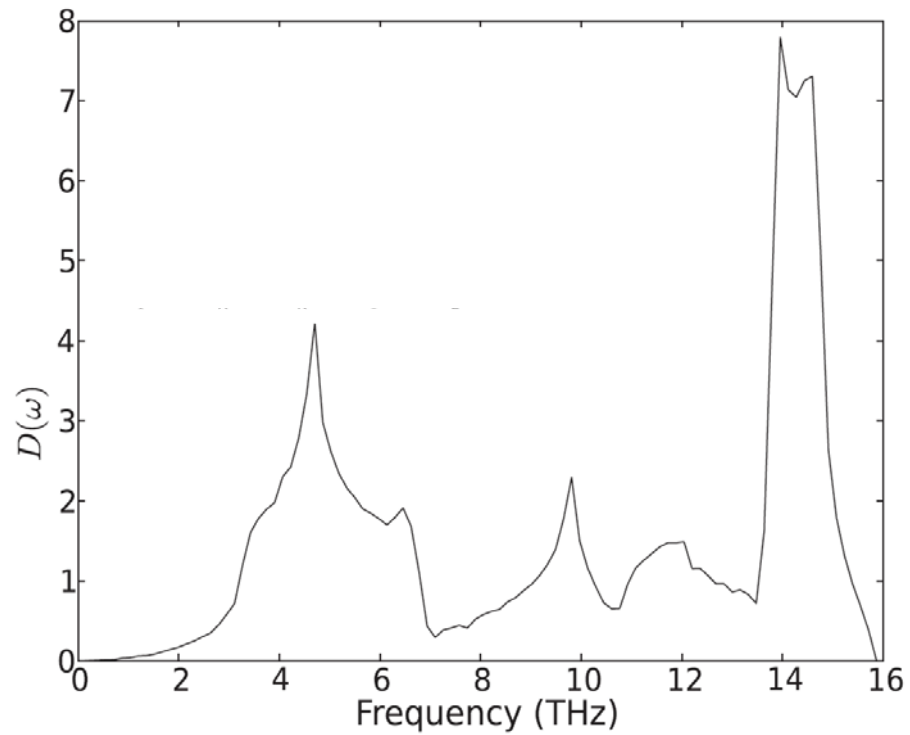
1. Bond stretching and bond-bending between atoms
2. Bond stretching between atoms and bond charges
3. Bond-bending between atoms and bond-charges
4. Effective charge



We used the same parameters as Weber for silicon in his original paper for bulk, thin films and nanowires.

# Bond charge model for silicon

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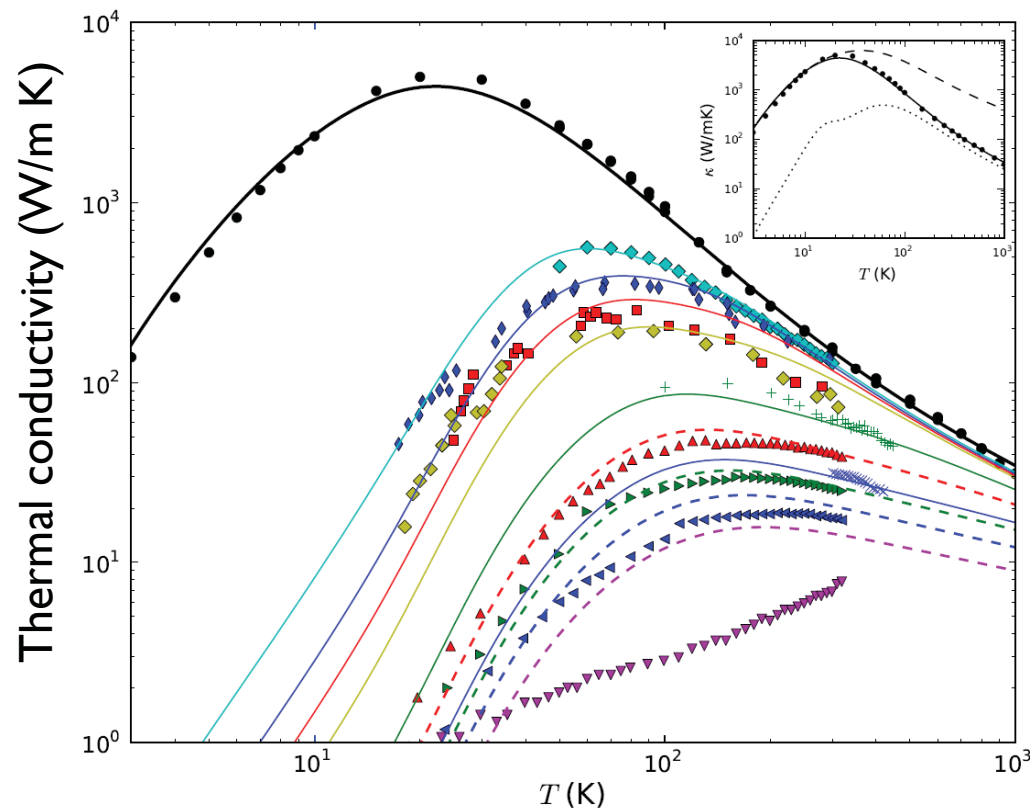


Phonon DOS and relation dispersion for silicon with the parameters obtained from W. Weber.

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# Comparison with experiment



The symbols in the corresponding colors represent experimental data from different references: Bulk (circles), micro thin films (squares and diamonds), nano thin films (crosses), and nanowires (triangles). The curves represent the thermal conductivity predicted from our model as a function of  $T$  for different Si samples. The dashed and dotted curves in the inset stand for the contributions of the kinetic and Ziman terms, respectively.



# Conclusions

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- ▶ We have analyzed the phonon thermal conductivity of bulk Si, thin films and Si nanowires within the classical limit
- ▶ A modified Gruyer-Krumhansl model, taking into account a geometrical factor obtained previously through a continuous-fraction approx. of the thermal conductivity
- ▶ The reason of using the GKM is that the N-processes are better treated and they are important in Si even at RT
- ▶ For the lattice dynamics, the bond charge model proposed by Weber has been used because it has a clear physical meaning and a small number of parameters
- ▶ We show that above 30 nm, a classical theory can fit the experimental data with the bulk parameters

